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INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE PROSECUTION OF THE SUBJECT APPLICATION

Applicants: L.W. Graham et al. Attorney Docket No.: SEMT116060
Application No.: 09/429,446 Group Art Unit: 1741
Filed: October 28, 1999 Examiner: W. Leader
Title: METHOD, CHEMISTRY, AND APPARATUS FOR NOBLE METAL ELECTROPLATING ON A MICROELECTRONIC WORKPIECE

U.S. PATENT DOCUMENTS

*Examiner Cite	Kind	Date		
Initials No. Document No. Code (mm/dd/yyyy) Name				
<u>WL</u> U20 5,789,320 08/04/1998 Andricacos et al.				

Examiner William Leader Date Considered 9/2002

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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